

Amendments to the Specification:

Please amend the CROSS-REFERENCE TO RELATED APPLICATIONS section as follows:

CROSS-REFERENCE TO RELATED APPLICATIONS

The present application relates to the following applications, all of which are incorporated herein by reference. Additional materials are incorporated by reference in other sections of this application.

[0001] 1. U.S. Patent Application No. 10/080,914 titled METHOD AND APPARATUS FOR MANUALLY AND AUTOMATICALLY PROCESSING MICROELECTRONIC WORKPIECES ~~(Attorney Docket No. 29195-8173US)~~ filed concurrently herewith;

[0002] 2. U.S. Patent Application No. 09/875,300 titled TRANSFER DEVICES FOR HANDLING MICROELECTRONIC WORKPIECES WITHIN AN ENVIRONMENT OF A PROCESSING MACHINE AND METHODS OF MANUFACTURING AND USING SUCH DEVICES IN THE PROCESSING OF MICROELECTRONIC WORKPIECES ~~(Attorney Docket No. 29195-8153US)~~ filed June 5, 2001;

[0003] 3. U.S. Patent Application No. 10/080,910 ~~(Attorney Docket No. 29195-8153US2)~~, titled MICROELECTRONIC WORKPIECE TRANSFER DEVICES AND METHODS OF USING SUCH DEVICES IN THE PROCESSING OF MICROELECTRONIC WORKPIECES, filed concurrently herewith; and

[0004] 4. Published PCT Application No. PCT/US99/14414, titled AUTOMATED SEMICONDUCTOR PROCESSING SYSTEM, filed June 25, 1999.